

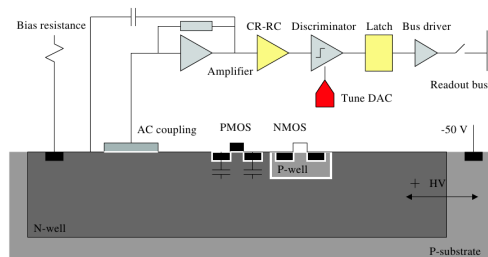
First Measurements with HV-MAP Sensor

Tobias Weber

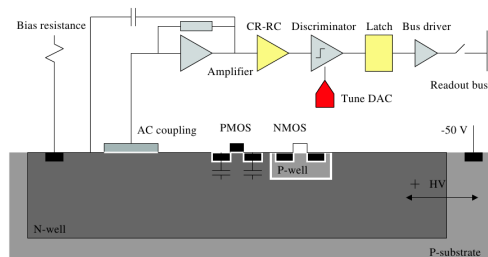
Helmholtz Institut Mainz

PANDA Collaboration Meeting

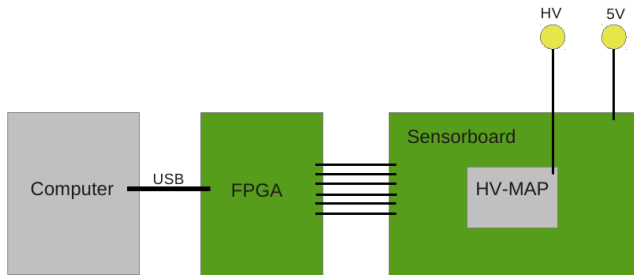
10.12.12



- ▶ fast charge collection
- ▶ high radiation tolerance
- ▶ thickness of 50 μm
- ▶ low power consumption ($\approx 20 \mu\text{W}/\text{pixel}$)



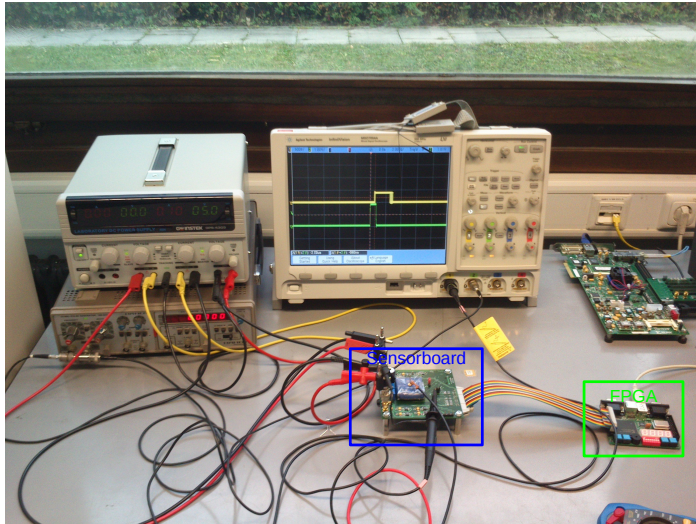
- ▶ Time-over-Threshold
- ▶ self-triggering
- ▶ 10-20 MHz readout



MuPix2 Test Chip

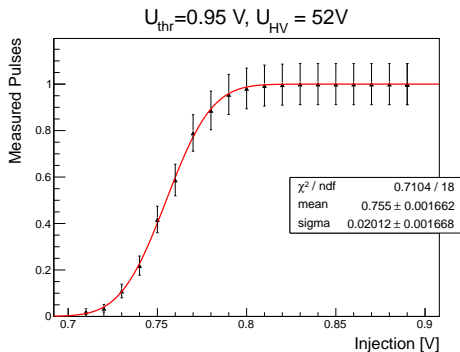
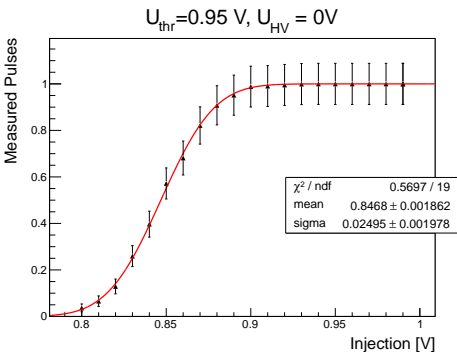
- ▶ 180 nm technology
- ▶ 42 x 36 pixels with $27 \times 40 \mu\text{m}^2$
- ▶ pixel logic on FPGA (Spartan 2)

Tests in Mainz



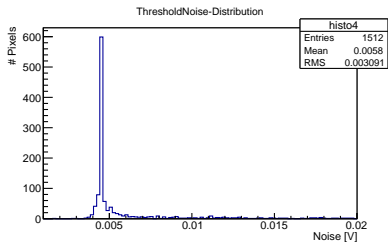
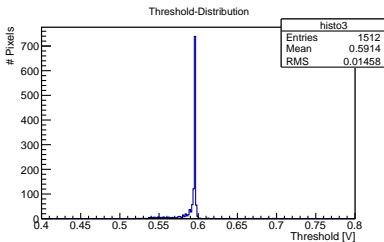
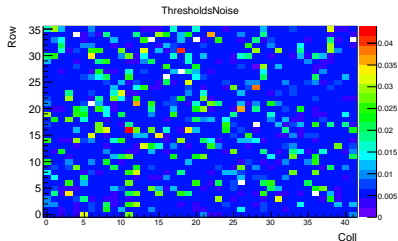
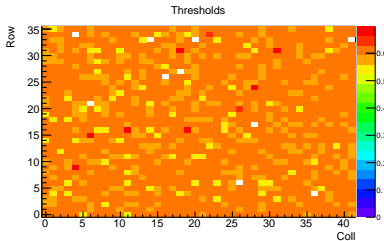
Pixel Noise

- ▶ inject sequence of test pulses
- ▶ count detected pulses

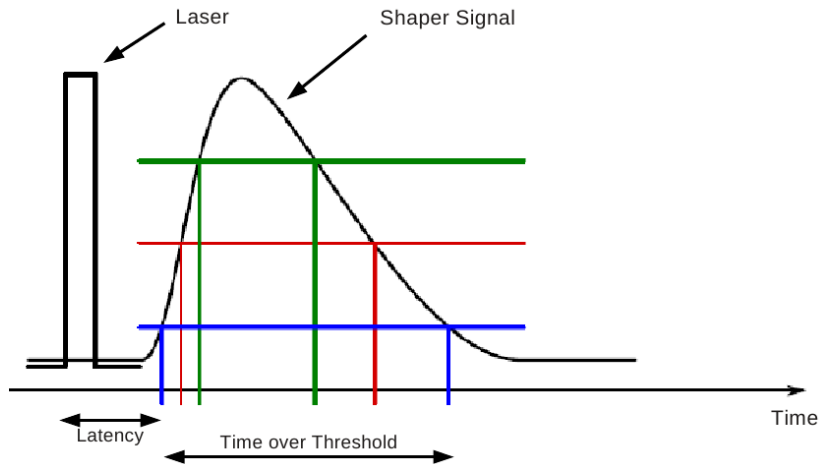


- ▶ reduction of pixel noise and threshold with high voltage
- ▶ $(S/N)_{\text{HV}} \approx 38$

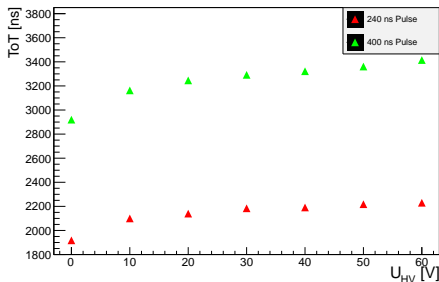
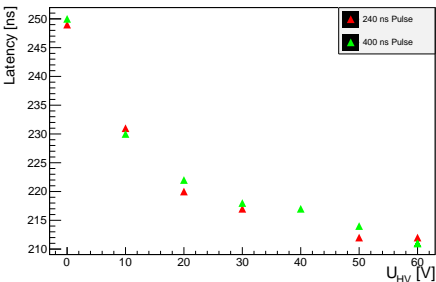
Pixel Noise



Latency and ToT Measurement

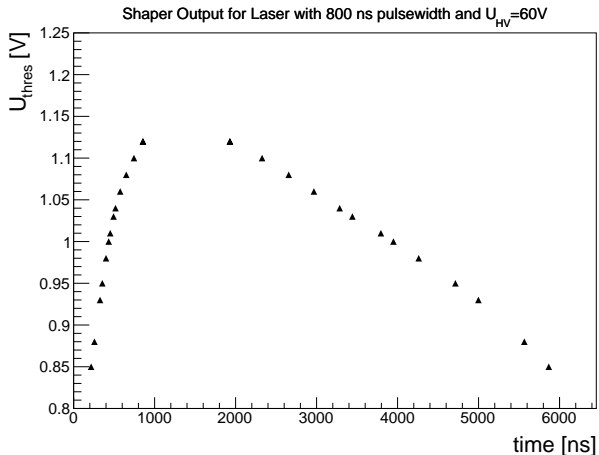


Latency and ToT Measurement



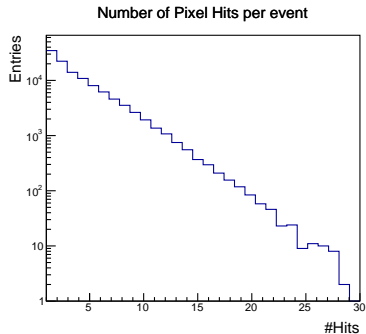
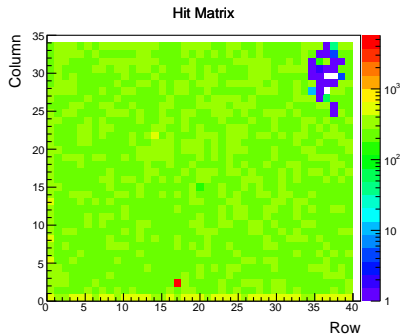
- ▶ latency decreases with growing high voltage
- ▶ Time-over-threshold increases with high voltage
- ▶ both effects most prominent between 0 and 20 V

Shaper Signal with Laser Diode



- shaper signal typical for CR-RC
- shaping time of 6 μs

Measurements with ^{90}Sr (different Sensor)



- ▶ pixel close to readout logic more active
- ▶ up to 30 pixel hits per readout frame

- ▶ further measurements with MuPix2
 - pixel noise
 - double pulse resolution
 - temperature behavior
- ▶ new version of HV-MAP (MuPix3) end of November
 - 80 x 80 μm^2 pixel size
 - faster shaping time ($\approx 1 \mu\text{s}$)
 - pixel and column logic
 - ⇒ new readout board (January 2013)
- ▶ readout of MuPix3 with optical link